

Notice of References Cited	Application/Control No. 10/684,900		Applicant(s)/Patent Under Reexamination KUSTERS ET AL.	
	Examiner NEVEEN ABEL JALIL		Art Unit 2165	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0191911	10-2003	Kleinschnitz et al.	711/154
*	B	US-2003/0220951	11-2003	Muthulingam et al.	707/205
*	C	US-2004/0015672	01-2004	Masse, Wayne P.	711/173
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	L	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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